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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet 1 of 2

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Application Number	09/724,784
Filing Date	11/28/00
First Named Inventor	Unger
Group Art Unit	1772
Examiner Name	Unassigned
Attorney Docket Number	20174C-003000US

U.S. PATENT DOCUMENTS

Examiner Initials *	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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Examiner
Signature

D. L. Unger

Date
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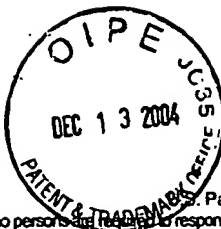
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OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS			
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~	1	Ahn et al., "Fluid Micropumps Based on Rotary Magnetic Actuators," <u>Proceedings of 1995 IEEE Micro Electro Mechanical Systems Workshop (MEMS '95)</u> , held in Amsterdam, Netherlands on 1/29-2/2/95, pgs. 408-412 (1995).	
~	2	Benard et al., "A Titanium-Nickel Shape-Memory Alloy Actuated Micropump," <u>Proceedings of Transducers '97</u> , 1997 International Conference on Solid-State Sensors and Actuators, held in Chicago, IL, 6/16-19/1997, 1:361-364 (1997).	
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Examiner Signature	<i>[Signature]</i>	Date Considered	3/4/05
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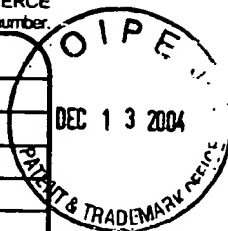
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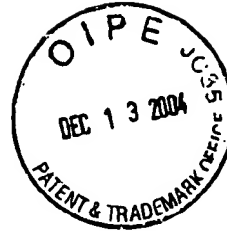
Application Number	09/724,784
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First Named Inventor	Marc A. Unger
Group Art Unit	1772
Examiner Name	Unassigned
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		Number	Kind Code ² (if known)			
W	1	6,174,365	B1	Sanjoh	01-16-2001	
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W	3	5,876,187		Afromowitz et al.	03-02-1999	
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✓	20	WO	99/17093	A1		04-08-1999		
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✓	22	EP	999 055	A2		10-05-2000		
✓	23	EP	845 603	A1		06-03-1998		
✓	24	EP	829 360	A2		03-18-1998		
✓	25	EP	779 436	A2		06-18-1997		
✓	26	EP	706 004	A2		04-10-1996		
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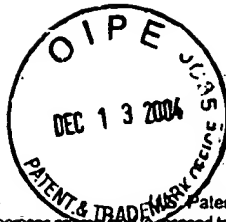
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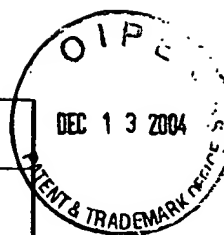
Sheet 1 of 3

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First Named Inventor	Marc A. Unger
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Attorney Docket Number	20174003000

OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS

Examiner Initials *	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
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		First Named Inventor	Marc Unger
		Art Unit	1732-1772
		Examiner Name	Allan W. Olsen
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Sheet	of 1		

NON PATENT LITERATURE DOCUMENTS			
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u	1	CARTER et al., Protein Crystallization Using Incomplete Factorial Experiments, the Journal of Biological Chemistry, 1979, pp. 12219-12223, Vol. 254, No. 23.	
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